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Edwards EXT-555H Technical Specifications

Main inlet flange DN160ISO-K / DN160CF DN25NW Outlet flange Interstage port (Hi variants) DN25NW 1/8 inch BSP Vent port 1/8 inch BSP Purge port Inlet pumping speed* 540 I s⁻¹ N_2 580 I s⁻¹ He 500 I s⁻¹ H_2 510 I s⁻¹

Interstage pumping speed (Hi variants)

8 I s⁻¹ 6 l s⁻¹ He 8 I s⁻¹ H_2

Compression ratio

>10¹⁰ N_2 10⁸ He 10⁶ H_2 >10¹⁰ Ar <10⁻¹⁰ mbar Ultimate pressure (CF variant) Recommended backing pump RV12

Maximum continuous inlet pressure (N2, He, H2)**

forced air cooled, 30 °C ambient 1x10⁻³ mbar 5x10⁻⁴ mbar forced air cooled, 35 °C ambient 2x10⁻³ mbar water cooling at 15 °C 50000 rpm Nominal rotational speed

Start time to 90% speed

EXC250 5 min EXC300 6.5 min EXDC160 8 min Cooling method forced air / water

Ambient air temperature for forced air cooling

Recommended cooling water flow

15 I h⁻¹ rate (water at 15 °C) 10 - 20 °C Water temperature 80 °C Maximum inlet flange temperature <60 dBA Noise level at 1m

Maximum magnetic field (standard envelopes)

<7 mTAxial < 3 mT Radial

Maximum magnetic field (martensitic envelopes)

Axial < 50 mTRadial < 50 mT

Recommended controllers EXC250, EXC300

Quiescent power consumption



0 °C - 35 °C

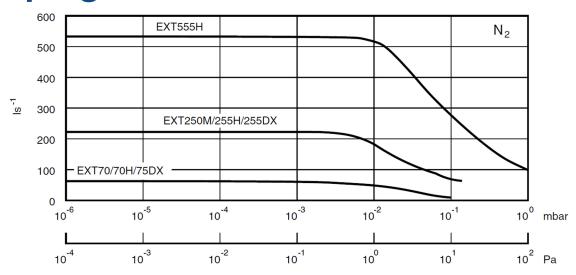
Measured without inlet screen. Inlet screens are supplied fitted and reduce speed by up to 20%

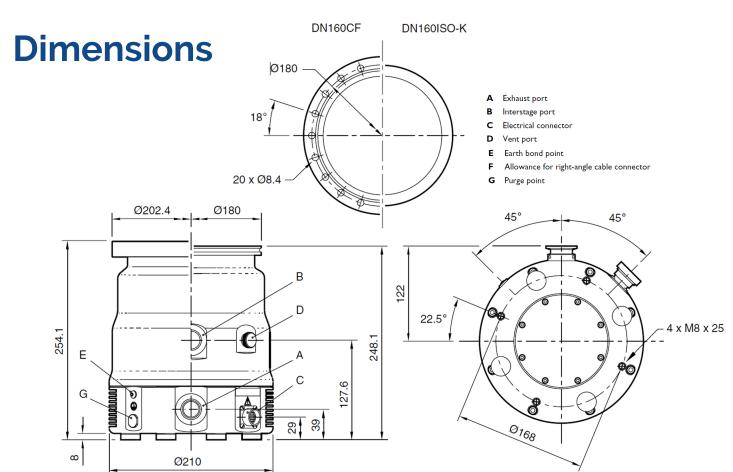
With backing pressure < 0.3 mbar. Above this inlet pressure rotational speed drops.

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Pumping Curves





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Features & Benefits

- state of the art technology
- reliable, hydrocarbon-free, high vacuum
- compatible with TIC turbo and instrument controller
- multiple communication modes available
- high critical backing pressures / high compression ratios
- · low vibration performance
- ceramic bearing
- enhanced monitoring cabability including pump speed, power & temperature

Applications

- analytical instrumentation
 mass spectroscopy
 electron microscopy
- metrology · sample preparation · surface science · high energy physics
- · lasers · research laboratories · opthalmic coating · thin film deposition
- · optical coating · lighting · solar: photovoltaics & thermal